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http://www.nikonsmallworld.com

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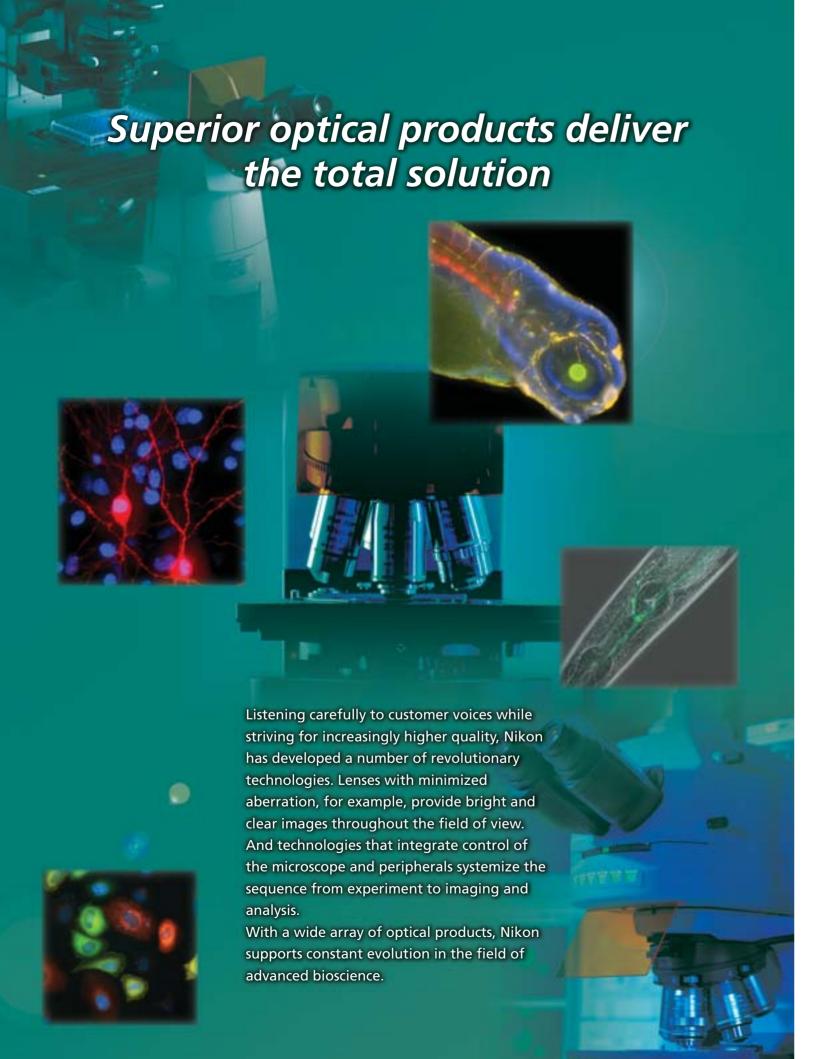
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Biological Microscopes





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^{*1} Nikon Advanced Modulation Contrast

^{*2} Brighter than 100W

Inverted Microscopes

Inverted Research Microscopes

CFI60 New

ECLIPSE Ti Series

Ultimate solution for advanced imaging methods in live cell research

- Ti-E with motorized focusing and motorized four-port changeover, Ti-U with manual four-port changeover and Ti-S with manual two-port changeover
- High-speed multi-channel screening is possible by fast motorized control (Ti-E)
- Perfect Focus System (PFS) keeps in focus in real-time during long-term observation (Ti-E)
- Imaging software NIS-Elements provides total system control for 6D time-lapse imaging (Ti-E)
- "Full intensity" external phase contrast unit allows use of specialized objectives without a phase ring and acquisition of high-quality images with high NA objectives
- Nikon original stratum structure allows simultaneous mounting of multiple fluorescence turrets and simultaneous acquisition of multiple wavelengths with two cameras including optional back port
- By attaching a HUB controller, desired components such as TIRF and filter turret, in addition to the stage and nosepiece can be motorized



Ti-E configuration with motorized accessories



Ti-U configuration with epi-fluorescence illuminator

Ti-S

Accessories for Ti Series

Motorized/Manual Laser TIRF Illuminator Unit (for Ti-E/U)

- Enables visualization of a single molecule with extraordinary high S/N ratio
- Imaging within approx. 100 nm from the coverslip-specimen interface with an evanescent wave
- The motorized TIRF system enables motorized control of laser incident angle from a PC or remote controller as well as storage and recall of up to four angles
- Laser TIRF, surface reflection interference contrast, and epi-fluorescence observations are switchable
- TIRF objective with correction ring adjusts image deteriorations caused by temperature changes





Epi-fl Illuminator Unit with White Light TIRF (for Ti-E/U/S)



- Handy and cost-effective TIRF observation using white light such as mercury illumination
- White light TIRF, oblique light fluorescence, surface reflection interference contrast, and epifluorescence observations are switchable
- The wide wavelength band of white light makes multiple wavelength TIRF observation possible by changing the filter

TIRF Photo Activation Illuminator Unit (for Ti-E/U)



- A laser TIRF illuminator, photo activation unit and epi-fluorescence illuminator have been combined in a single unit
- Switching between the three functions is easy

Photo Activation Illuminator Unit (for Ti-E/U)



- Photo activation and photo conversion using proteins such as PA-GFP and Kaede are possible
- Realizes photo activation of an arbitrary determined spot
- Photo activation and epi-fluorescence observation are switchable

Inverted Microscopes

ECLIPSE TS100/TS100-F



New Apodized Phase Contrast objectives visualize minute details with greater resolution Also supports fluorescence and NAMC*

- Adopts CFI60 infinity optics for this class of
- Apodized Phase Contrast objectives visualize minute details within a specimen
- Both models support fluorescence microscopy
- Nikon Advanced Modulation Contrast (NAMC) observation is possible, enabling colorless and transparent samples in a plastic dish to be observed in high relief, a procedure not possible with DIC
- Eyepiece tube inclination and comfortable eye-point height for natural viewing posture when sitting or standing
- Low-profile 195mm-high stage with transparent acrylic stage ring for easy confirmation of objective in use
- Quintuple backward-facing nosepiece offers plenty of clearance for easy rotation

*Nikon Advanced Modulation Contras



TS100-F (Trinocular tube model)

Accessories for Inverted Microscopes

Oil Hydraulic Micromanipulation Systems

NT-88-V3 Series (for Ti-E/U/S, TS100/100F)

The NT-88-V3 series provides microscopic and precise specimen micromanipulation for experiments in the fields of IVF (In Vitro Fertilization), especially ICSI (Intracytoplasmic Sperm Injection), transgenic biotechnology, and electrophysiology.

- Assembly of the micromanipulator is fast and easy due to the one-piece, extremely stable mounting adapter
- Easy-to-use hanging-type joystick
- Smooth operation without needle drift
- Needle top can be easily adjusted thanks to alignment indicators on the coarse unit
- Compact and stable design (less than half the size of conventional models)

(Manufactured by Narishige Co., Ltd.)

Water Hydraulic Micromanipulation System

MHW-3 (for Ti-E/U/S, TS100/100F)

Needle drift caused by changes in room temperature has been decreased to the lowest possible level. Optimized for long hours of micromanipulation, such as in electrophysiologic patch-clamp experiments.

(Manufactured by Narishige Co., Ltd.)



Accessories for Inverted Microscopes

Stage Incubation System INU Series (for Ti-E/U/S, TS100/100F)

It sustains the internal temperature at 37°C with humidity of 90% and CO₂ of 5% to keep the specimen in a stable and precise condition for about three days.

(Manufactured by Tokai Hit Co., Ltd.)

Thermal Plate Warmer

ThermoPlate MATS Series (for Ti-E/U/S, TS100/100F)

A temperature controllable stage ring with a glass heating plate keeps the specimen at a set temperature. Temperature is adjustable from room temperature to 50°C in 0.1°C increments.

(Manufactured by Tokai Hit Co., Ltd.)



HG Precentered Fiber Illuminator "Intensilight" (for Ti-E/U/S, i-series upright microscopes, AZ100/100M multipurpose zoom microscopes)

Long-life mercury light source, suitable for fluorescence

- Precentered lamp—easy lamp replacement, no alignment required
- Average lamp lifetime as long as 2,000 hours
- Fiber connection—less heat and electrical noise conducted to microscope body. Ideal for time lapse and other lengthy observations
- Constant, non-fluctuating light intensity through a direct current (DC) lighting
- Motorized model available shutter and light intensity controllable from PC or remote controller



Time Lapse Imaging System

BioStation IM

The perfect solution for stable, long-term time-lapse imaging

- Incorporates a microscope, an incubator and a cooled CCD camera into a single system
- Consistent environmental control of temperature at 37°C, humidity at 95% or higher, and CO₂ concentration at 5%
- Total control of temperature of whole unit minimizes focus drift caused by temperature change
- Motorized objective lens movable in X, Y and Z directions eliminates focus drift caused by stage movement
- Exceptional phase contrast and fluorescence imaging quality
- Easy operation with fully motorized control from PC
- Optional ergo controller offers operational feel similar to that of an actual microscope
- Convenient accessories include the perfusion components that fit inside the incubator and a quadrant culture dish that does not cause the media's meniscus



Upright Microscopes

Motorized Advanced Research Microscope

CF160

ECLIPSE 90i

Efficient automation in observation and imaging

- Motorized operation model with control capability from buttons on the microscope body, ergo controller, DS-L2 camera controller or a PC
- High-precision motorized focusing
- Motorized switching between observation methods, for example, from epi-fluorescence to DIC
- Aperture and brightness are automatically adjusted following the change of the magnification
- In a combination with the DS series camera, auto focus in brightfield is possible. Microscope status data can be automatically recorded
- Revolutionary Fly-Eye optics offers an excellent even illumination for digital imaging
- Improved DIC prisms offer optimal contrast and resolution



CF160

Advanced Research Microscope

ECLIPSE 80i

Revolutionary optics perfect for digital imaging

- Manual operation model, but with the motorizing capability to, for example, switch magnifications or excitation filters by using the DIH-E digital imaging head, motorized DIC nosepiece or motorized epi-fluorescence illuminator
- In a combination with the DS series CCD camera, microscope status data can be automatically recorded with images
- Revolutionary Fly-Eye optics offer an excellent even illumination for digital imaging
- Improved DIC prisms offer optimal contrast and resolution



Upright Microscopes

Clinical & Laboratory Microscopes

ECLIPSE 55i/50i

The ultimate in comfort that takes clinical microscopy to new heights

- 55i incorporates LED illumination-featuring a constant color temperature and lower power consumption-which is paramount for brightfield
- 50i adopts a halogen light source with a built-in ND8 filter for various observation methods
- Ergonomic Tube matches varying eyepoints. A digital camera is also attachable with an optional DSC port
- Hard finish stage with smooth XY movement, featuring height adjustable stage handle
- A retrofittable compact Cytodiagnostic Unit enables quick switching between 10x and 40x using a hand switch. When attached to 55i, it also keeps a constant brightness
- Refocusing stage facilitates specimen exchange
- Dedicated Epi-Fluorescence illuminator incorporates a 4position filter turret with a lock mechanism to one or two positions



55i configured with Ergonomic Tube

CF160

Accessories for i Series Upright Microscopes

Motorized Universal Epi-Fluorescence Attachment (for 80i)

Remote controller has CW/CCW switches for rotation of epifluorescence filter turret and epi-shutter IN/OUT switch



Drawing Tube (for 90i, 80i, 55i, 50i)

Microscope images can be easily traced while being observed

• Original optical system delivers images of 1x without a relay lens

• Low-magnification drawing kit available for drawing wider areas



Simple Polarizing Accessories (for 90i, 80i, 50i)

For observing birefringent samples such as collagen, amyloids and crystals







Simple Polarizing set B (with swing-out rotatable polarizer)



Sextuple Nosepiece with Analyzer Slot (with swing-out rotatable polarizer)

Double Port (for 90i, 80i, 55i, 50i)

Mounted between a microscope body and trinocular tube, the double port enables the simultaneous mounting of two cameras.



Accessories for i Series Upright Microscopes

Sensitive Color Polarizing Accessories (for 90i, 80i, 50i)

For gout and pseudo-gout tests



Teaching Heads (for 90i, 80i, 50i)

The 50i can be configured with a two-person side-by-side or face-to-face version. The 90i/80i has versions that can handle up to 10 people. Structures can be selected flexibly, depending on use.



Thermal Plate Warmer

ThermoPlate MATS Series (for 90i, 80i, 55i, 50i)

ThermoPlate MATS-U505S facilitates the thermal control of the specimen being observed. (rectangular type, W142 x D115 mm) (Manufactured by Tokai Hit Co., Ltd.)



Quadrocular Adapter (for 90i, 80i, 55i, 50i)

Two cameras can be simultaneously mounted on a trinocular eyepiece tube via this adapter and switched.



Magnification Module (for 90i, 80i, 55i, 50i)

The turret system allows the intermediate magnification to be changed from 1x to 1.25x, 1.5x or 2x.



HG Precentered Fiber Illuminator "Intensilight" (for 90i, 80i, 55i, 50i, Ti-E/U/S inverted microscopes, AZ100/100M multi-purpose zoom microscopes)

See page 7 for details.

Upright Microscope

Clinical & Educational Microscope

ECLIPSE E200

Outstanding cost performance—striking image sharpness, operability and durability

- Adopts CFI60 infinity optics for this class of microscope. Plan objectives that excel in image flatness come standard
- One-touch refocusing stage for easier specimen handling
- Focusing knob and stage handle are low-positioned and equidistant from operator, permitting one-handed operation in natural posture
- Ergonomic binocular tube and eye-level risers are available for adjusting the eyepoint
- Anti-mold treated
- E200-F (model with field diaphragm) is also available
- Various accessories are available, such as dedicated epi-fluorescence attachment



Upright Microscope

Educational Microscope

ECLIPSE E100

High optical quality, simple operation and rigid design

- CFI optical system and dedicated objectives for flat images
- Siedentopf-type eyepiece tube and eye level adjustments; digital camera attachable to trinocular eyepiece tube
- Phase contrast observation for high-contrast viewing of transparent and colorless specimens
- Durable, easy-to-rotate quadruple nosepiece
- • Condenser comes with aperture diaphragm that has position-guide markings for 4/10/40/60/100x
- Anti-mold treatment for objectives, eyepieces, and eyepiece tube



E100 (Halogen lamp model)

Digital Microscope

COOLSCOPE II





- Simultaneous Micro/Macro image display
- Memory function
- One-click stage shift
- Auto Focus
- Auto aperture/brightness adjustment
- Images saved on CompactFlash cards or USB memory stick, as well as other PCs via USB connection
- Direct connection to a printer means images can be printed without the use of a PC
- Magnification
- Standard magnification type (5x, 10x, 20x, 40x)
- Low magnification type (2x, 4x, 20x, 40x)
- SXGA high-definition image quality

All-in-one digital microscope that transcends the current concept of a microscope On-monitor observation, mouse-click operation

- Minimal configuration with just a tower main unit, monitor and mouse
- Simple mouse clicks do the rest once the preparation is loaded
- Elimination of microscope setups and optical adjustments
- No more stooping over eyepieces—just observe the specimen on the monitor in a relaxed posture
- Built-in digital camera for one-click image save as you see it on the monitor
- Optional ergonomic controller provides an operational feel similar to that of an actual microscope
- Just connect COOLSCOPE II to a projector for conference
- Network capabilities enable observation and control of COOLSCOPE II via Internet Explorer—convenient for consultation from a remote place

Polarizing Microscopes

ECLIPSE LV100POL/50iPOL/E200POL



CFI60 infinity optics provide greater sharpness on polarizing regions

- CFI60 optics deliver world-class optical performance
- Excellent basic performance, operability, durability and, above all, outstanding image sharpness
- LV100POL is a research polarizing microscope that boasts twice the rigidity of conventional models and a brightness exceeding 100W (12V-50W model with centering quintuple nosepiece). The built-in Fly-Eye optics ensures uniform illumination, making it ideal for digital imaging
- ECLIPSE 50iPOL is compact yet possesses high functionality, such as a nosepiece with DIN standard compensator slot (6V-30W model with centering quintuple nosepiece)
- E200POL is a cost-efficient and extremely compact model (6V-20W model with quadruple nosepiece)







F200POI

Microscope for Patch Clamp Experiments

ECLIPSE FN1

CF160

Dedicated patch-clamp microscope with I-shaped body design—more room for smooth electrode manipulation

- Multi Patch System motorizes viewfield changeover without having to move the specimen and objective
- \bullet Corrects axial chromatic aberration up to IR light (to 850nm). New 40x and 60x objectives for crisp high resolution IR-DIC imaging
- \bullet 100x objective with NA 1.1 and working distance 2.5mm comes with a correction function for depth- and thermally-induced aberrations
- Vertical motion nosepieces enables magnification changes without moving Petri dish (15mm or less in height)
- Easy switching between IR light and reflected illumination
- \bullet With an optional variable magnification double port (0.35x, 2x, 4x), both wide field and high magnification observations can be carried out with a 16x objective alone



All objectives have wide approach angles and long working distances (45° and 3.5mm with 40x objective).

Configuration with Narishige micromanipulators and epi-fluorescence attachment

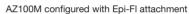
Multi-purpose Zoom Microscope

Multizoom AZ100/AZ100M

Continuously switchable magnifications, extending from macro to micro observation of the same specimen

- Covers a magnification range of 5x to 400x, thanks to 8x zooming optics and a unique triple nosepiece
- True on-axis observation and image capture are possible in the macro region
- Comes standard with an aperture stop
- Tilting trinocular eyepiece tubes can accommodate a digital camera
- Focusing can be achieved with either the AZ stand or stage controls
- Because the stand section offers an 85mm stroke and the stage section a 10mm stroke, even tall samples can easily be observed
- AZ100M with motorized focusing and motorized zooming makes it easy to capture Extended Depth of Focus (EDF) images
- HG Precentered Fiber Illuminator "Intensilight" can be used (See page 7 for details)







AZ100 configured with Epi-Fl attachment

Stereoscopic Microscopes

■ Parallel-optics System

- Nikon's unique OCC illumination (Oblique Coherent Contrast) is available with a C-DSD diascopic stand, allowing colorless, transparent samples to be observed in high relief
- Various accessories, such as epi-fluorescence attachment, teaching head, simple polarizing set, are available
- Evepiece tube is exchangeable from 20° inclination, low eyelevel, tilting eyepiece tube

Stereoscopic Zoom Microscope

SMZ1500

Top-of-the-line stereoscopic zoom microscope boasting a 15x zoom ratio, and high NA and resolution.



Configured with C-DSD diascopic stand

Stereoscopic Zoom Microscope

SMZ1000

A 10x zoom ratio stereoscopic microscope offering superb optical performance and ergonomic operability.



Configured with C-PS160 plain stand

Stereoscopic Zoom Microscope

SMZ800

An affordable stereoscopic zoom microscope with a 6.3x zoom ratio offering excellent optical performance and expandability.



Configured with C-PS plain stand

Stereoscopic Microscopes

■ Twin Objective System

Stereoscopic Zoom Microscopes

SMZ645/660 SMZ445/460

- SMZ645 and SMZ445 have 45° eyepiece inclination for comfortable viewing. SMZ660 and SMZ460 with 60° inclination are suitable for system integration
- Zoom ratio is 6.3x for SMZ645/660, 4.4x for SMZ445 and 4.3x for SMZ460
- The new hybrid type long-life LED stand features built-in diascopic and angle-adjustable episcopic illumination. Both illuminations can be used simultaneously





Stereoscopic Microscope

SM-5

Compact yet sturdy, its flexible design permits easy attachment to various instruments in production and quality control facilities at minimum costs.



Accessories for Stereoscopic Microscopes

Thermal Plate Warmer

ThermoPlate MATS Series (for diascopic stands)

ThermoPlate MATS series facilitates the thermal control of the specimen being observed. (Manufactured by Tokai Hit Co., Ltd.)



MATS-USMZSL (fitted with base of C-DSS/DSD/BD stands)



MATS-USMZSS (fitted with base of C-DS diascopic stand)



MATS-USMZR (ring type ø180mm)



MATS-U4020WF (wide working-area type W430 x D205 x H75-100mm; glass thickness 1.6mm)

Confocal Microscope Systems

Confocal Microscope

A1R/A1

The A1R with a revolutionary hybrid scanner realizes ultrafast and high-resolution imaging

- Hybrid scanner capable of high-speed imaging at 420 fps (512 x 32 pixels) allows simultaneous imaging and photo activation
- High-resolution imaging up to 4096 x 4096 pixels
- With the VAAS pinhole unit, flare can be eliminated and image brightness retained. Moreover, different sectioning can be simulated after image acquisition
- Dichroic mirror with 30% increased fluorescence efficiency provides high image quality



Configured with Ti-E

True Spectral Imaging Confocal Microscope

A1Rsi/A1si

High-performance spectral detector supports simultaneous excitation of multiple wavelengths

- Acquisition of 32 channels (512 x 32 pixels) at 24 fps in a single scan
- · Accurate, real-time spectral unmixing
- · Simultaneous excitation of four lasers
- V-filtering function adjusts total intensity of up to four desired spectral ranges individually, providing flexibility to handle new fluorescence probes



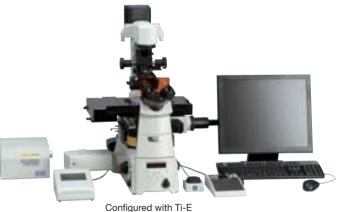
Configured with Ti-E

Confocal Microscope

C1 plus

Personal confocal microscope now supports FRAP

- 1000x optical zoom of ROI
- ROI scanning is possible with an optional AOM/AOTF
- Accommodates a greater variety of lasers with wavelengths ranging from 405 to 640nm
- 4-channel simultaneous acquisition such as 3-channel confocal plus DIC



True Spectral Imaging Confocal Microscope

C₁si

Spectra across a wide 320nm range captured with a

- High-speed, low-invasive imaging by a single scan acquisition
- Unmixing of spectral images without crosstalk
- Nikon's proprietary DEES and DISP technology for bright images
- Accuracy of spectra is maintained with diverse correction technologies



Configured with 90i

CCD Cameras

Digital Camera System for Microscopes

Digital Sight Series

The Digital Sight series offers a choice of seven camera heads and two control units, enabling an image capturing system to be assembled to suit each use.



Ultrahigh-resolution Cooled Color Camera Head DS-Ri1

- 12.7-megapixel, 2200TV line
 - high-definition images
 - Faithful reproduction of specimen color
 - Smooth display of live images
 - Reduces heat noise; captures fluorescence and darkfield images clearly



High-definition Cooled Color Camera Head

DS-Fi1c



New

· Cooling mechanism enables it to capture fluorescence and darkfield images clearly

High-definition 5.0-megapixel CCD

High-definition Color Camera Head

High-speed Cooled Monochrome Camera Head

megapixel CCD



DS-Fi1

DS-2MBWc

- High-definition 5.0-megapixel CCD
- High resolution and high frame rate
- High dynamic range and accurate color reproduction

• Cooling mechanism enables it to capture

fluorescence and darkfield images clearly

High-frame-rate and high-sensitivity 2.0-

High-sensitivity Cooled Monochrome Camera Head DS-Qi1



- High sensitivity equivalent to ISO 800
- Cooling mechanism reduces dark current to 0.7e-/ pixel/s and readout noise to 8e- rms, realizing a wide dynamic range
- Superior quantitivity with linearity of >98%

High-speed Color Camera Head DS-2Mv



• High-frame-rate, 2.0-megapixel CCD • Suitable for monitoring of microscopy images

PC-use Control Unit DS-U2



- Versatile image capture, processing, measurement and analysis when coupled with imaging software NIS-Elements
- High-speed image transfer to PC via USB 2.0 connection
- Compact, space-saving design
- Allows control of Nikon motorized microscopes

Standalone Control Unit



- Built-in high-definition 8.4-in. large LCD monitor
- Camera can be operated via the GUI of the LCD monitor, eliminating the necessity of PC connection
- Various digital interfaces including USB 2.0 connection
- Pre-programmed imaging modes for different observation methods
- Allows control of the Nikon motorized microscopes 90i/80i

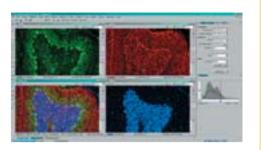
Software

Imaging Software

NIS-Elements

NIS-Elements is an integrated platform of imaging software developed by Nikon to achieve comprehensive control of microscope image capture and document data management.

NIS-Elements handles multidimensional imaging tasks flawlessly with support for capture, display, peripheral device control, and data management & analysis of images (up to six-dimensional images).



Available in three distinct packages scaled to meet user needs and applications:



NIS-Elements Advanced Research

NIS-Elements AR is optimized for advanced research applications. It features fully automated acquisition and device control through full 6D (X, Y, Z, Lambda (Wavelength), Time, Multipoint) image acquisition and analysis.



NIS-Elements Basic Research

NIS-Elements BR is suited for standard research applications. It features acquisition and device control through 4D (up to four dimensions can be selected from X, Y, Z, Lambda (Wavelength), Time, Multipoint) acquisition.



NIS-Elements Documentation

NIS-Elements D supports color documentation requirements in bio-research, clinical and industrial applications, with basic measuring and reporting capabilities.

Various convenient plug-ins are available for advanced imaging and analysis capabilities.

Multidimensional Capturing

NIS-Elements can combine X, Y, Z, Lambda (wavelength), Time and Multi points within one integrated platform for multidimensional imaging (depending on the capability of the software). All combinations of multidimensional images can be linked together in one

ND2 file sequence using an efficient workflow and intuitive GUL

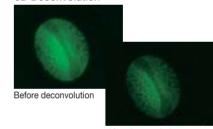


X, Y, Z, λ (Wavelength), T, Multipoint acquisition

3D/2D Real-time Deconvolution

Haze and blur of the fluorescence image can be eliminated from the captured 3D image or from the 2D live preview image. (Separate plug-in for 3D and 2DRT)

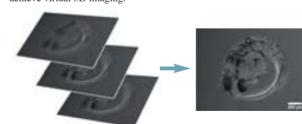
3D Deconvolution



2D Real-time Deconvolution

Extended Depth of Focus

With the Extended Depth of Focus (EDF) plug-in, images that have been captured in a different Z-axis can be used to create an all-in-focus image. Also, it is possible to create stereovision images & 3D surface images to achieve virtual 3D imaging.



All-in-focus image created from a sequence of Z-stack images

Database

NIS-Elements has a powerful image database module that supports image and meta data. Various databases & tables can easily be created and

images can be saved to the database via one simple mouse-click. Filtering, sorting and multiple grouping are also available according to the database field given for each image.



Visit www.nis-elements.com for more detailed information

CFI60 Objectives

Type	Use	Model	Immersion	NA	W.D. (mm)	Cover glass thickness	Correction ring	Spring loaded	Brightfield	Darkfield	DIC*5	Phase contrast	Polarizing	Fluoresc Visible light	ence	Ti-E PFS
		4x		0.10	30.00				0				Δ	O	0.	
		10x		0.25	7.00	_			0	Δ			Δ	0		\vdash
		LWD 20x		0.40	3.90	0.17			0	0			Δ	0		\vdash
	Brightfield	40x		0.65	0.65	0.17		/	0	0			Δ	0		\vdash
	(CFI)	LWD 40xC		0.55	2.7-1.7	0-2.0	/		0	0			Δ	0		+
		60x		0.80	0.30	0.17		1	0	•			Δ	0		\vdash
		100xH	Oil	1.25	0.23	0.17		1	0				Δ	0		\vdash
		100xSH (with iris)	Oil	0.5-1.25	0.23	0.17		1	0	0			Δ	0		\vdash
		P 4x		0.10	30.00				0				0	0		\vdash
		P 10x		0.25	7.00	_			0	Δ			0	0		\vdash
	Polarizing	LWD P 20x		0.40	3.90	0.17			0	0			0	0		+
	(CFI)	P 40x		0.65	0.65	0.17		1	0	0			0	0		\vdash
at		P 100xH	Oil	1.25	0.23	0.17		1	0				0	0		+
Achromat		DL 10x		0.25	7.00	_			0	Δ		© PH1	Δ	Δ		\vdash
chi		LWD DL 20x		0.40	3.90	0.17			0	0		© PH1	Δ	Δ		+
⋖	Dhaaa	LWD DL 20xF		0.40	3.10	1.2			0			© PH1	Δ	Δ		+
	Phase contrast	DL 40x		0.65	0.65	0.17		/	0	0		© PH2	Δ	Δ		+
	(CFI)	LWD DL 40x		0.55	2.7-1.7	0-2.0	1	-	0	00		© PH2	Δ	Δ		+
		DL 100xH	Oil	1.25	0.23	0.17		√	0			© PH3	Δ	Δ		+
		BM 10x*1	- 511	0.25	7.00	0.17		•	0			© PH1	Δ	Δ		+
		ADL 10x	-	0.25	6.20	1.2			0			© PH1	Δ	Δ		+
	Apodized	LWD ADL 20xF		0.40	3.10	1.2			0			© PH1	Δ	Δ		+
	phase contrast	LWD ADL 40x F	-	0.55	2.10	1.2			0			© PH1	Δ	Δ		\vdash
	(CFI)	LWD ADL 40xC		0.55	2.7-1.7	0-2.0	/		0	0		© PH2	Δ	Δ		+
	Advanced	NAMC 10x		0.33	6.20	1.2	· ·		0			© FП2	Δ	Δ		\vdash
	modulation	LWD NAMC 20xF		0.40	3.10	1.2			0					Δ		\vdash
	contrast	LWD NAMC 20XP			2.7-1.7				0							\vdash
	(CFI)			0.55	3.20	0-2.0	1		0				_	Δ		\vdash
		UW 1x		0.04									Δ	Δ		₩
		UW 2x		0.06	7.50	_			0				Δ	Δ		₩
		4x		0.10	30.00				0				Δ	0		┼
	Brightfield	10x		0.25	10.50	-			0	Δ			Δ	0		₩
	(CFI Plan)	20x		0.40	1.20	0.17			0	00			Δ	0		₩
		40x	0"	0.65	0.56	0.17		/	0	0			Δ	0		₩
Ħ		50xH	Oil	0.90	NCG0.35			√	0	•			Δ	0		_
Plan Achromat		100xH	Oil	1.25	0.20	0.17		✓	0			@ =	Δ	0		_
ç	Phase	DL 10x		0.25	10.50	_			0	Δ		© PH1	Δ	Δ		_
Ă	contrast	DL 20x		0.40	1.20	0.17			0	0		© PH1	Δ	Δ		_
Pa	(CFI Plan)	DL 40x		0.65	0.56	0.17		✓	0	0		© PH2	Δ	Δ		
		DL 100xH	Oil	1.25	0.20	0.17		✓	0			© PH3	Δ	Δ		_
	No cover	NCG 40x		0.65	0.48	0		✓	0	0			Δ	0		_
	glass	NCG 60x (CF objective)*2		0.85	0.35	0		✓	0	•			Δ	0		_
	(CFI Plan)	NCG 100x		0.90	0.26	0		✓	0	•			Δ	0		_
	Super long	SLWD 20x		0.35	24.00	0			0	0			Δ	0		
	WD (CFI L	SLWD 50x		0.45	17.00	0			0	0			Δ	0		\perp
	Plan EPI)	SLWD 100x		0.70	6.50	0			0	0			Δ	0		\perp
	Brightfield	ELWD 20xC		0.45	8.2-6.9	0-2.0	1		0	0	0		0	0	0	•
~	(CFI S Plan			0.60	3.6-2.8	0-2.0	1		0	0	0		0	0	0	•
Plan Fluor*3	Fluor)	ELWD 60xC		0.70	2.6-1.8	0.1-1.3	1		0	0	0		0	0	0	
Ⅱ	Apodized	ELWD ADM 20xC		0.45	8.2-6.9	0-2.0	/		0	0		O PH1		0	0	•
an	phase contrast (CFI	ELWD ADM 40xC		0.60	3.6-2.8	0-2.0	/		0	0		O PH2		0	0	•
SP	S Plan Fluor)	ELWD ADL 60xC		0.70	2.6-1.8	0.1-1.3	1		0	0		© PH2		0	0	
	Advanced modulation contract	ELWD NAMC 20xC		0.45	7.40	0-2.0	1		0					0		
	modulation contrast (CFI S Plan Fluor)	ELWD NAMC 40xC		0.60	3.10	0-2.0	1		0					0		
		4x		0.20	15.50	_			0				Δ	0	O Wide	•
		10x		0.50	1.20	0.17		✓	0	0	0		Δ	0	O Wide	•
**	Brightfield	20x		0.75	1.00	0.17		✓	0	0	0		Δ	0	O Wide	•
.vo	(CFI S Fluor)	40x		0.90	0.30	0.11-0.23	/	✓	0	•	0		Δ	0	O Wide	
S Fluor*4	. 1001)	40xH	Oil	1.30	0.22	0.17		√w/stopper	0		0		Δ	0	O Wide	•
S		100xSH (with iris)	Oil	0.5-1.3	0.20	0.17		1	0	0			Δ	0	O Wide	
	Phase contrast	DL 20x*1		0.75	1.00	0.17		√	0	0		© PH2		0	0	•
		DL 40x*1		0.90	0.30	0.11-0.23	/	1	0	•		© PH2		0	0	•

The below letters, when attached to the end of model numbers, indicate the respective features.

H: oil immersion type
F: for use with 1.2mm-thick cover glass
C: with correction ring
NCG: for use without cover glass

SH: with iris
WI: water immersion type
W: water dipping type
Mi: multi immersion (oil, water, glycerin) type

Note 2. Cover glass thickness can be used without cover glass
 use without cover glass

Note 3. Darkfield microscopy
Possible with the following
△: universal condenser (dry) and darkfield ring
○: above and darkfield condenser (dry)

■: darkfield condenser (oil)

Note 4. Phase rings are classified by objective NA PHL: for Plan Fluor 4x PH1: NA 0.25 - 0.5 PH2: NA 0.25 - 0.95 PH3: NA 1.0 - 1.40 PH4: NA 1.45 - 1.49 EXT: compatible with external phase contrast of the Ti series

Note 5. Fluorescence microscopy (UV)

Δ: possible with visible light that has a longer wavelength than the excitation light used for DAPI

○: suitable

○: recommended for best results Wide: high transmittance with an ultraviolet wavelength range of up to 340nm

2	II.	Medal	lanana araba	N/A	W.D.	Cover	Correction	Spring	Delaktor	David	DIC+F	Phase	Delector	Fluoresco	ence	Ti
) yba	Use	Model	Immersion	NA	(mm)	glass thickness	ring	loaded	Brightfield	Darkfield	DIC*5	contrast	Polarizing	Visible light	UV	PF
Olliversal Flan Flag	No cover	P 5x		0.15	23.50	_			0				0	0	0	
	glass	P 10x		0.30	17.50	0			0	Δ			0	0	0	
	polarizing	P 20x		0.45	4.50	0			0	0			0	0	0	\perp
	CFI LU Plan Fluor EPI)	1 30%		0.80	1.00	0		1	0	•			0	0	0	
	Tidol Li i)	P 100x		0.90	1.00	0		1	0	•			0	0	0	
		4x		0.13	17.10	_			0				Δ	0	0	
		10x		0.30	16.00	0.17			0	Δ	0		0	0	0	
		20x		0.50	2.10	0.17			0	0	0		0	0	0	
		ELWD 20xC		0.45	8.1-7.0	0-2.0	✓		0	0	0		0	0	0	
		20xMi	Oil, water, glycerin	0.75	0.51-0.35 0.51-0.34 0.49-0.33	0-0.17	1	1	0	0•	0		0	0	0	
	Brightfield	40x		0.75	0.66	0.17		1	0	0	0		0	0	0	
	(CFI Plan Fluor)	ELWD 40xC		0.60	3.7-2.7	0-2.0	✓		0	0	0		0	0	0	
	i iuoi)	40xH	Oil	1.30	0.20	0.17		√w/stopper	0		0		0	0	0	Т
		60x		0.85	0.40-0.31	0.11-0.23	1	✓	0	•	0		0	0	0	
		ELWD 60xC		0.70	2.1-1.5	0.5-1.5	1		0	0	0		0	0	0	\top
		60xSH (with iris)	Oil	0.50-1.25	0.22	0.17		✓	0	0	0		0	0	0	
		100x		0.90	0.32-0.28	0.14-0.20	1	✓	0	•	0		0	0	0	
		100xH	Oil	1.30	0.16	0.17		√w/stopper	0		0		0	0	0	Ť
		100xSH (with iris)	Oil	0.50-1.30	0.16	0.17		1	0	0	0		0	0	0	1
		DL 4x		0.13	16.40	1.2			0			O PHL		0	0	\top
		DLL 10x		0.30	16.00	0.17			0	Δ		© PH1		0	0	
	Phase	DL 10x		0.30	15.20	1.2			0	Δ		© PH1		0	0	†
	contrast	DLL 20x		0.50	2.10	0.17			0	0		© PH1		0	0	1
	(CFI Plan Fluor)	DLL 40x		0.75	0.66	0.17		1	0	0		© PH2		0	0	$^{+}$
		DM 40xDS		0.75	0.66	0.17		1	0	0		© PH2		0	0	+
		DLL 100xH	Oil	1.30	0.16	0.17		√w/stopper	0			© PH3		0	0	+
	Apodized phase contrast	ADH 100xH	Oil	1.30	0.16	0.17		√w/stopper	0			© PH3		0	0	
	(CFI Plan Fluor)	2x	0	0.10	8.50	_		тилосоррог	0			90	0	0	Δ	+
		4x		0.10	20.00	_			0				0	0	Δ	+
		10x		0.45	4.00	0.17			0	Δ	0		0	0	Δ	+
						0.17		,	0		0		0	0		+
		20x VC 20x		0.75	1.00			1	0	00			0	0	Δ	+
				0.75	1.00	0.17				00	0		_		Δ	+
	Brightfield (CFI Plan	40x	0.1	0.95	0.16-0.12	0.11-0.23	1	/	0	•	0		0	0	Δ	-
	(CFI Plan Apo)	40xH	Oil	1.00	0.16	0.17		√w/stopper	0		0		0	0	Δ	+
		60x		0.95	0.17-0.13	0.11-0.23	1	1	0	•	0	E)/T	0	0	Δ	+
		VC 60xH	Oil	1.40	0.13	0.17		1	0		0	EXT PH3-60x	0	0	Δ	
		VC60xA WI	Water	1.20	0.31-0.28	0.15-0.18	1	1	0	•	0	EXT PH3-60x	0	0	0	
		VC 100xH	Oil	1.40	0.13	0.17		✓	0		0	EXT PH3-100x	0	0	Δ	
		NCG 100xH	Oil	1.40	0.16	0		1	0		0		0	0	Δ	1
		DM 20x		0.75	1.00	0.17		1	0	0		© PH2		0	Δ	\top
	Dhess	DM 40x		0.95	0.16-0.12	0.11-0.23	1	1	0	•		© PH2		0	Δ	\top
	Phase contrast	DM 40xH	Oil	1.00	0.16	0.17		√w/stopper	0	•		© PH3		0	Δ	\dagger
	(CFI Plan	DM 60x		0.95	0.17-0.13	0.11-0.23	1	✓ · · · ·	0	•		© PH2		0	Δ	\dagger
	Apo)	DM 60xH	Oil	1.40	0.13	0.17		1	0			© PH3		0	Δ	\dagger
		DM 100xH	Oil	1.40	0.13	0.17		/	0			© PH3		0	Δ	+
						0.13-0.19 (23°C)	,					EXT				+
	Evanescent (CFI Apo)	TIRF 60xH	Oil	1.49	0.12	0.15-0.21(37°C) 0.13-0.19 (23°C)	/		0		0	PH4-60x EXT	0	0		+
		TIRF 100xH	Oil	1.49	0.12	0.14-0.20(37°C)	✓				0	PH4-100x		0		

Type	Use	Model	Immersion	NA	W.D.	Cover glass	Correction		Brightfield	Darkfield	DIC*5	Phase	Polarizing	Fluoresc	ence	Near- infrared
_	USG	WIOGE	IIIIIIGISIOII	IVA	(mm)	thickness	ring	loaded	Drigittieiu	Darkiiciu	DIC	contrast	li olalizilig	Visible light	UV	DIC
	Brightfield (CFI Plan Fluor)	10xW	Water	0.30	3.50	0			0	Δ	0		Δ	0	0	0
	D. C. Luffer Lil	20xW	Water	0.50	2.00	0			0	0	0		0	0	0	0
	Brightfield (CFI Fluor)	40xW	Water	0.80	2.00	0			0	•	0		0	0		0
ing	(0)	60xW	Water	1.00	2.00	0			0	•	0		0	0	0	0
효	Brightfield	40xW NIR	Water	0.80	3.50	0			0	•	0		Δ	0	Δ	0
Ž.	(CFI Apo)	60xW NIR	Water	1.00	2.80	0			0	•	0		Δ	0		0
Water Dipping	Brightfield (CFI Plan)	100xW	Water	1.10	2.50	0	1		0	•	0		Δ	0		0
	Phase contrast (CFI Fluor)	DLL 40xW	Water	0.80	2.00	0			0	•		© PH2	Δ	0	0	0
	Brightfield (CFI75)	LWD 16xW*6	Water	0.80	3.00	0			0	•	0	·	Δ	0	0	0

Note 6. Brightfield/DIC/Polarizing/Fluorescence (visible light) microscopy

△ : possible but not recommended □ : recommended for best results
○ : suitable

Note 7. Ti-E PFS

• : compatible with PFS (Perfect Focus System) of the Ti-E

^{*1} Make-to-order *2 To use with the CFI60 optics microscope (not possible in E400), an objective conversion adapter is necessary.

*3 Axial chromatic aberration is corrected in shorter wavelength ranges than the Plan Fluor series to improve image clarity.

*4 Transmits an ultraviolet light up to a 340nm wavelength

*5 See page 20 for compatible prisms *6 Dedicated for FN1 (CFI75 objective)

Note 1. Model numbers

Combinations of DIC Prisms and Objectives

For Ti series inverted microscopes

				LWD Dry, Mot	torized System	Condenser LW	D Dry		HNA Conde	nser Lens Dry	1		HNA Conde	nser Lens Oil	
		Star	ndard	High C	Contrast		esolution	Star	ndard		esolution	Sta	ndard		esolution
		Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider
10x	Plan Fluor 10x Plan Apo 10x S Fluor 10x	LWD N1 Dry	10x	-	_			-	_			-	_		
20x	Plan Fluor 20x Plan Apo 20x S Fluor 20x Plan Fluor 20x MI Plan Apo VC 20x	LWD N2 Dry	20x	LWD N1 Dry	20x-C			HNA N2 Dry	20x			HNA N2 Oil	20x		
	Plan Fluor ELWD 20xC	LWD N1 Dry	20x I												
	S Plan Fluor ELWD 20xC	LWDINIDIY	20x II]					_			_			
	Plan Fluor 40x Plan Apo 40x S Fluor 40x	LWD N2	40x I	LWD N1 Dry	40x I-C			HNA N2	40x I			HNA N2	40xl		
40x	Plan Fluor 40x Oil S Fluor 40x Oil	Dry	40x II					Dry	40x II			Oil	40x II		
	Plan Apo 40x Oil		40x III						40x III				40x III		
	Plan Fluor ELWD 40xC S Plan Fluor ELWD 40xC	LWD N1 Dry	40x IV					-	_			-	_		
	Plan Apo 60x Plan Apo VC 60x 0il Apo TIRF 60x 0il	LWD N2	60x I			LWD NR	60x I	HNA N2	60x I	HNA NR	60x I	HNA N2	60x I	HNA NR	60x I
60x	Plan Fluor 60x Oil Plan Fluor 60x	Dry	60x II	-	_	Dry	60x II-R	Dry	60x II	Dry	60x II-R	Oil	60x II	Oil	60x II-R
	Plan Apo VC 60xA WI		60x IV	1			60x IV-R	1	60x IV		60x IV-R	1	60x IV	1	60x IV-R
	Plan Fluor ELWD 60xC S Plan Fluor ELWD 60xC	LWD N1 Dry	60x III			-	_	-	=	-	_	-	_	-	_
100x	Plan Apo VC 100x Oil Apo TIRF 100x Oil Plan Fluor 100x	LWD N2 Dry	100x I			LWD NR Dry	100x I-R	HNA N2 Dry	100x I	HNA NR Dry	100x I-R	HNA N2	100x I	HNA NR	100x I-R
	Plan Fluor 100x Oil Plan Fluor 100x Oil Iris],,	100x II			-19	100x II-R	-7	100x II	,	100x II-R	"	100x II		100x II-R

For 90i/80i upright microscopes

			Universal C	Condenser Dry/Mot	orized Universal Co		DIC Condenser Oil				
			ndard		Contrast		esolution		ndard		solution
		Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider	Condenser Module	DIC Slider
	Plan Apo 10x (Eco)										
10x	Plan Fluor 10x	N1 Dry	10x		_				_		
	S Fluor 10x										
	Plan Fluor 20x										
	Plan Fluor 20x MI										
	Plan Apo 20x	N2 Dry	20x	N1 Dry	20x-C			N2 Oil	20x		
20x	S Fluor 20x										
	Plan Apo VC 20x										
	Plan Fluor ELWD 20xC	N1 Dry	20xl		_		_		_		_
	S Plan Fluor ELWD 20xC	IN DIY	20xII								
	Plan Fluor 40x										
	Plan Apo 40x		40x I	N1 Dry	40xI-C				40x I		
	S Fluor 40x	N2 Dry						N2 Oil			
40x	Plan Fluor 40x Oil	INE DIY	40x II					NE OII	40x II		
	S Fluor 40x Oil										
	Plan Apo 40x Oil		40x III						40x III		
	Plan Fluor ELWD 40xC	N1 Dry	40x IV						_		
	S Plan Fluor ELWD 40xC		10/11								
	Plan Apo 60x										
	Plan Apo VC 60x Oil		60x I				60x I-R		60x I		60x I-R
	Apo TIRF 60x Oil	N2 Dry			_	NR Dry		N2 Oil		NR Oil	
60x	Plan Fluor 60x Oil		60x II				60x II-R		60x II		60x II-R
	Plan Fluor 60x			_							
	Plan Fluor ELWD 60xC	N1 Dry	60x III				_		_		_
	S Plan Fluor ELWD 60xC	-		1							
	Plan Apo VC 100x Oil										
	Plan Apo 100x NCG Oil		100x I				100x I-R		100x I		100x I-R
100x	Apo TIRF 100x Oil	N2 Dry					N2 Oil		NR Oil		
	Plan Fluor 100x	-		4						-	
	Plan Fluor 100x Oil		100x II				100x II-R		100x II		100x II-R
	Plan Fluor 100x Oil Iris										

For FN1 microscope for patch clamp experiments

		FN-C LWD Cond	lenser
		Condenser Module	DIC Slider
10x	Plan Fluor 10xW	N1 Dry	10x
16x	LWD 16xW (CFI75)		16xl
20x	Fluor 20xW		20x
40x	Apo 40xW NIR		40xIII
	Fluor 40xW	N2 Dry	40/111
60x	Apo 60xW NIR		60xl
	Fluor 60xW		UUAI
100x	Plan 100xW		100x-III

Epi-fluorescence Filters

Filter Characteristics

	Filters	Wavelengths	Characteristics	i series, Ti series	E series, TS100
	UV-1A	EX 365/10 DM 400 BA 400	Narrow band pass—only 365nm (i line) of Mercury spectrum used Narrow band pass minimizes auto-fluorescence and photo-bleaching	/	/
U	UV-2A	EX 330-380 DM 400 BA 420	Standard filter block for UV	1	/
V	UV-2B	EX 330-380 DM 400 BA 435	Darker background than UV-2A	1	1
	UV-2E/C (DAPI)	EX 340-380 DM 400 BA 435-485	For DAPI, cutting off FITC (green) and TRITC (red) Soft-coated type for high signal/noise Band-Pass Barrier Filter used to cut off green and red	1	✓
V	V-2A	EX 380-420 DM 430 BA 450	Standard filter block for V	1	1
В	BV-1A	EX 435/10 EM 455 BA 470	Narrow band pass—only 435nm (g line) of Mercury spectrum used Narrow band pass minimizes auto-fluorescence and photo-bleaching	/	
V	BV-2A	EX 400-440 DM 455 BA 470	•Standard filter block for BV	1	/
	B-1A	EX 470-490 DM 505 BA 520	Narrower excitation range than B-2A FITC+Counter-stain (TRITC, PI)	1	
	B-1E	EX 470-490 DM 505 BA 520-560	For FITC (green), cutting off Rhodamine red Band-Pass Barrier Filter used to cut off red	1	
В	B-2A	EX 450-490 DM 505 BA 520	Standard filter block for B For FITC + Counter-stain (TRITC, PI)	1	/
D	B-2E	EX 450-490 DM 505 BA 520-560	Similar to FITC For FITC (green), cutting off Rhodamine red Band-Pass Barrier Filter used to cut off red		1
	B-2E/C (FITC)	EX 465-495 DM 505 BA 515-555	Soft coated type for high signal/noise For FITC (green), cutting off Rhodamine red Band-pass Barrier Filter used to cut off red	1	1
	B-3A	EX 420-490 DM 505 BA 520	Wide band pass—recommended for halogen illumination only	1	✓
	G-1B	EX 546/10 DM 575 BA 590	Narrow band pass—only 546nm (e line) of Mercury spectrum used Narrow band pass minimizes auto-fluorescence and photo-bleaching	1	1
0	G-2A	EX 510-560 DM 575 BA 590	Standard filter block for G	1	✓
G	G-2B	EX 510-560 DM 575 BA 610	•610nm barrier provides darker background and deep red emission	1	
	G-2E/C (TRITC)	EX 540/25 DM 565 BA 605/55	For TRITC (Rhodamine) Soft coated type for high signal/noise Band-Pass Barrier Filter used to cut off reds above 643nm	1	✓
Υ	Y-2E/C (Texas Red)	EX 540-580 DM 595 BA 600-660	For Texas Red® Soft coated type for high signal/noise Band-Pass Barrier Filter used to cut off reds above 660nm	1	1

Filters for Fluorescent Protein

Filters	Wavelengths	i series, Ti series	E series, TS100
BFP	EX380/30, DM420, BA460/50	✓	
CFP	EX436/20, DM455, BA480/40	✓	
CFP HQ*	EX420-445, DM450, BA460-510	✓	
GFP-L	EX480/40, DM505, BA510	✓	1
GFP-B	EX480/40, DM505, BA535/50	✓	1
GFP HQ*	EX455-485, DM495, BA500-545	✓	
YFP	EX500/20, DM515, BA535/30	✓	
YFP HQ*	EX490-500, DM510, BA520-560	1	

^{*}Each filter/mirror has a very sharp rising edge at the corresponding wavelength, minimizing signal crossover.

Other Filters

Filters	Wavelengths	i series, Ti series	E series, TS100
СуЗ	EX535/50, DM565, BA610/75	1	
Cy5	EX620/60, DM660, BA700/75	1	
Cy7	EX710/75, DM750, BA810/90	1	

Multi-Band Filters

Filters	Abbreviations	Applications	i series, Ti series	E series, TS100
Dual	F-R	FITC, Rhodamine	✓	✓
	F-T	FITC, Texas Red	✓	✓
	D-F	DAPI, FITC	✓	
Triple	D-F-R	DAPI, FITC, Rhodamine	1	1
	D-F-T	DAPI, FITC, Texas Red	✓	/

Filters for SMZ1500/1000/800

Filters	Wavelengths
GFP-L	EX460-500, DM505, BA510
GFP-B	EX460-500, DM505, BA510-560

Note:

The lineup is constantly updated. For the latest information, please contact your local Nikon representative. The excitation filters or barrier filters in each filter cube are interchangeable. For custom setup, blank cubes without filters are also available. Please consult with your local Nikon distributor for a complete list of filters locally available or inquire about special custom filter combinations.

Dimensional Diagrams

